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Application/Control No.	Applicant(s)/Patent under Reexamination	
10/662,330	OHIRA, TAKASHI	
Examiner	Art Unit	
Flena Tsov	1762	

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SEARCHED				
Class	Subclass	Date	Examiner	
427	508, 553, 558	8/31/2006	ET	
updi	rted	1107	ET	
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INTERFERENCE SEARCHED			
Subclass	Date	Examiner	
			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXM	/IR	
EAST/EPO, JPO, Derwent	8/31/20	06 E	r	
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